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				APPLICANT: Holger RUCKER et al.					
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UNITED STATES PATENT DOCUMENTS									
EXAM. INITIAL		DOCUMENT NUMBER	DATE	INVENTOR/ASSIGNEE	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE		
	US	2002/0117733	Aug. 29, 2002	Michael Farjami, Esq. Marco Racanelli					
	US	6,642,553	Nov. 4, 2003	Juergen Drews et al.					
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	EP	1 128 422 A1	Aug. 29, 2001	EP					
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		H.J. Osten et al., <i>The Effect of Carbon Incorporation on SiGe Heterobipolar Transistor Performance and Process Margin</i> ; IEEE 1997 0-7803-4100 (pages 32.4.1 - 32.4.4).							
Examiner (To be assigned) /Long Pham/				Date: 10/23/2009					